Casimir free energy of metallic films: Discriminating between Drude and plasma model approaches

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We investigate the Casimir free energy of a metallic film either sandwiched between two dielectric plates or in vacuum. It is shown that even for a thin film of several tens of nanometer thickness the Casimir free energy and pressure calculated with the Lifshitz theory using the Drude model and the plasma model approaches take significantly different values and can be easily discriminated. According to our results, the classical limit is already achieved for films of about 100-nm thickness if the Drude model approach is used in calculations. In this case the classical expressions for the Casimir free energy and pressure are common for both configurations considered. If the plasma model approach is used, the classical limit is not achieved for any film thickness. Instead, the Casimir free energy and pressure are decreasing exponentially to zero. When the plasma frequency goes to infinity, the Casimir free energy obtained using the Drude model approach goes to a nonzero limit in contradiction with expectations. If the plasma model approach is used the free energy of metallic film goes to zero in the limit of infinitely large plasma frequency. All analytic results are accompanied by numerical computations performed for an Au film and sapphire plates. The possibilities to observe the predicted effects discriminating between the Drude and plasma model approaches are discussed.

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I. INTRODUCTION

During the last few years the Casimir effect, which manifests itself as free energies and forces between closely spaced material boundaries, attracted much experimental and theoretical attention [1-3]. The in-depth reason responsible for the Casimir effect is an existence of the zero-point and thermal fluctuations of the electromagnetic field whose spectrum is modified by the boundary conditions. Applications of the Casimir effect extend from the nanoscale science [4-6], atomic physics [7–10], condensed matter physics [11–16], to the elementary particles, astrophysics, and cosmology [17–20]. The basic theory describing the Casimir effect is the Lifshitz theory of dispersion forces [3,21]. It was originally formulated for the plane parallel boundary surfaces and recently generalized for the bodies of arbitrary geometrical shape [22,23]. This generalization was used for interpretation of experiments on measuring the Casimir interaction between sinusoidally [24-27] and rectangular [28,29] corrugated surfaces.

Calculations of the Casimir free energy and pressure using the Lifshitz theory require the values of dielectric permittivities of boundary materials at the imaginary Matsubara frequencies. The latter are obtained by means of the Kramers-Kronig relations from the measured data for the frequency-dependent complex index of refraction. Taking into account that these data are available only at frequencies exceeding some minimum frequency ω_m , they are usually extrapolated down to zero frequency using some model [3]. Theoretically, the most straightforward way of extrapolation taking into account the relaxation properties of conduction electrons is by means of the Drude model (the so-called Drude model approach). It was shown, however, that the results of all precise experiments on measuring the Casimir interaction between metallic surfaces, performed by means of micromachined oscillator [30-33] and atomic force microscope [34-37], exclude the predictions of the Lifshitz theory using the Drude model approach at the confidence level up to 99.9%. The same measurement results were found to be consistent [30–37] with the predictions of the Lifshitz theory using the plasma model for extrapolation of the optical data to zero frequency (i.e., the plasma model approach) which disregards the relaxation properties of conduction electrons. Quantitatively, an agreement of the measurement data with the plasma model approach at higher than 90% confidence level was demonstrated in Ref. [38].

On the other hand, it was found that the Casimir entropy calculated for metals with perfect crystal lattices using the Drude model approach goes to a nonzero limit depending on the parameters of a system when the temperature vanishes in violation of the third law of thermodynamics, the Nernst heat theorem. This was proved for both nonmagnetic [39-41] and magnetic [42] metals. The plasma model approach was shown to be in agreement with the Nernst heat theorem [39-42]. Thus, both the experimental data and thermodynamics are surprisingly in favor of the model which should not be applicable at low, quasistatic, frequencies and is usually used in the literature [43] in the region of infrared optic, where the relaxation processes do not play any role. On the other hand, the Bohr-van Leeuwen theorem, which states that the classical transverse electromagnetic field has no influence on the matter in the state of thermal equilibrium, was shown to be in agreement with the Drude model approach and in contradiction with the plasma model approach [44]. This conflict between the two theorems could indicate that even in the classical limit, where the major contribution to the Casimir force does not depend on the Planck constant, the quantum effects still remain important. It should be also remembered that for dielectric test bodies the measured Casimir force of several recent experiments agrees with theoretical predictions of the Lifshitz theory only if the conductivity at a constant current (the dc conductivity) is omitted [45-49]. If the dc conductivity is included in calculation, the obtained theoretical results are in contradiction with the measurement data [45-49] and violate the Nernst heat theorem [50-53].

We emphasize that all precise experiments mentioned above were performed at short separation distances below a micrometer between the test bodies. At these separations, differences in theoretical predictions of the Drude and plasma model approaches do not exceed a few percent. In spite of the fact that the total measurement error was typically by an order of magnitude lower, it is desirable to find the experimental configurations where the differences in theoretical predictions of the two approaches were more sizable. In this regard, an employment of large separation distances above $6 \,\mu m$, where the predictions of both approaches differ by a factor of two, is not helpful because the force magnitudes become too low.

To avoid this problem, Refs. [54–56] proposed the use of differential force measurements, where theoretical predictions of the Drude model approach for the difference of two forces are larger than those of the plasma model approach by up to a factor of 1000. The measurement results of this experiment have been reported recently [57]. They demonstrated an exclusion of the Drude model approach and consistency with the plasma model one. Note, however, that for the plasma model approach the predicted magnitudes of the force differences in this experiment are of the order of 0.1 pN. To compare, theoretical errors in the calculated force differences are of the same order of magnitude.

In this paper we investigate the Casimir free energy and pressure for metallic films, either in vacuum or sandwiched between two thick dielectric plates. We show that this configuration possesses some unusual properties, as compared with the more standard geometries of two plates interacting through a vacuum gap or a liquid intervening layer. Specifically, we demonstrate that even for rather thin nonmagnetic metallic films (of several tens nanometer thickness) the predictions of the Lifshitz theory using the Drude and plasma model approaches differ significantly and can be easily discriminated. Note that the Casimir energy of metallic films in vacuum was considered in Refs. [58,59]. However, this and below results were not obtained because all computations using the Drude model have been performed only at zero temperature. Next we show that with increasing film thickness the Casimir free energy and pressure go to the classical limiting values which do not depend on the material properties of metallic film and dielectric plates if the Drude model approach is used in calculations. Unlike the standard geometries, the classical limit is already achieved for the film of about 110-nm thickness. For the plasma model approach, the dependence on the material properties of the film and the plates is preserved up to relatively large film thicknesses. In this case, with increasing film thickness, the Casimir free energy and pressure are decreasing exponentially to zero and the differences with theoretical predictions of the Drude model approach reach several orders of magnitude. It is shown that the Casimir free energy of a metallic film described by the Drude model approach goes to a nonzero classical value when the plasma frequency goes to infinity. This is contrary to physical intuition because the field fluctuations cannot penetrate inside an ideal metal. If the plasma model approach is used, the free energy of a metallic film goes to zero when the plasma frequency goes to infinity.

All the analytic results are illustrated by numerical computations performed for the example of an Au film situated either in vacuum or sandwiched between two Al_2O_3 (sapphire) plates.

The paper is organized as follows. In Sec. II we briefly formulate the basic equations of the Lifshitz theory adapted for our configuration and present the analytic results for the Casimir free energy. Section III is devoted to numerical computations of the Casimir free energy of an Au film in vacuum or between two sapphire plates of different thicknesses and temperatures. In Sec. IV similar results are obtained for the Casimir pressure. Section V contains our conclusions and discussion of the Drude and plasma model approaches. In the appendix some details of our analytic evaluations are presented.

II. CASIMIR FREE ENERGY OF METALLIC FILMS

We consider the three-layer system consisting of a thick plate (semispace), described by the dielectric permittivity $\varepsilon^{(-1)}(\omega)$, followed by a metallic film of thickness *a* described by the dielectric permittivity $\varepsilon^{(0)}(\omega)$ and another thick plate (semispace) characterized by the dielectric permittivity $\varepsilon^{(+1)}(\omega)$. The system is assumed to be in thermal equilibrium at temperature *T*. The Lifshitz formula for the Casimir free energy per unit area is given by [3,21]

$$\begin{aligned} \mathcal{F}(a,T) &= \frac{k_B T}{2\pi} \sum_{l=0}^{\infty} \int_0^\infty k_\perp dk_\perp \\ &\times \left\{ \ln \left[1 - r_{\mathrm{TM}}^{(0,+1)}(i\xi_l,k_\perp) r_{\mathrm{TM}}^{(0,-1)}(i\xi_l,k_\perp) e^{-2ak_l^{(0)}(k_\perp)} \right] \right\} \\ &+ \ln \left[1 - r_{\mathrm{TE}}^{(0,+1)}(i\xi_l,k_\perp) r_{\mathrm{TE}}^{(0,-1)}(i\xi_l,k_\perp) e^{-2ak_l^{(0)}(k_\perp)} \right] \right\}. \end{aligned}$$

where k_B is the Boltzmann constant, $\xi_l = 2\pi k_B T l/\hbar$ with l = 0, 1, 2, ... are the Matsubara frequencies, $k_{\perp} = |\mathbf{k}_{\perp}|$ is the magnitude of the projection of the wave vector on the plane of plates, and the prime multiples the term with l = 0 by 1/2. The reflection coefficients for two independent polarizations of the electromagnetic field, transverse magnetic (TM) and transverse electric (TE), are expressed as

$$r_{\rm TM}^{(0,\pm1)}(i\xi_l,k_{\perp}) = \frac{\varepsilon_l^{(\pm1)}k_l^{(0)}(k_{\perp}) - \varepsilon_l^{(0)}k_l^{(\pm1)}(k_{\perp})}{\varepsilon_l^{(\pm1)}k_l^{(0)}(k_{\perp}) + \varepsilon_l^{(0)}k_l^{(\pm1)}(k_{\perp})},$$

$$r_{\rm TE}^{(0,\pm1)}(i\xi_l,k_{\perp}) = \frac{k_l^{(0)}(k_{\perp}) - k_l^{(\pm1)}(k_{\perp})}{k_l^{(0)}(k_{\perp}) + k_l^{(\pm1)}(k_{\perp})},$$
(2)

where the following notation is introduced:

$$k_{l}^{(n)}(k_{\perp}) = \sqrt{k_{\perp}^{2} + \varepsilon_{l}^{(n)} \frac{\xi_{l}^{2}}{c^{2}}},$$
(3)

and $\varepsilon_l^{(n)} \equiv \varepsilon^{(n)}(i\xi_l)$ with $n = 0, \pm 1$.

If both thick plates are made of common material, one should put $\varepsilon_l^{(-1)} = \varepsilon_l^{(+1)}$ in Eqs. (2) and (3). In this case we have $r_{\text{TM},\text{TE}}^{(0,+1)}(i\xi_l,k_{\perp}) = r_{\text{TM},\text{TE}}^{(0,-1)}(i\xi_l,k_{\perp})$. Below we also consider the Casimir free energy for a metallic film in vacuum. This case is obtained from Eqs. (2) and (3) by putting $\varepsilon_l^{(-1)} = \varepsilon_l^{(+1)} = 1$.

As a result, Eq. (2) takes the form,

$$r_{\rm TM}^{(0,+1)}(i\xi_l,k_{\perp}) = r_{\rm TM}^{(0,-1)}(i\xi_l,k_{\perp}) = \frac{k_l^{(0)}(k_{\perp}) - \varepsilon_l^{(0)}q_l(k_{\perp})}{k_l^{(0)}(k_{\perp}) + \varepsilon_l^{(0)}q_l(k_{\perp})},$$

$$r_{\rm TE}^{(0,+1)}(i\xi_l,k_{\perp}) = r_{\rm TE}^{(0,-1)}(i\xi_l,k_{\perp}) = \frac{k_l^{(0)}(k_{\perp}) - q_l(k_{\perp})}{k_l^{(0)}(k_{\perp}) + q_l(k_{\perp})},$$
 (4)

where

$$q_l(k_{\perp}) = \sqrt{k_{\perp}^2 + \frac{\xi_l^2}{c^2}}.$$
 (5)

The analytic results of this section are obtained for metallic films described by the Drude or by the plasma model (the interband transitions of core electrons are taken into account in numerical computations performed in Secs. III and IV). Thus, the dielectric permittivity of the Drude model at the imaginary Matsubara frequencies is given by

$$\varepsilon_{l,D}^{(0)} = 1 + \frac{\omega_p^2}{\xi_l[\xi_l + \gamma(T)]},$$
(6)

where ω_p is the plasma frequency and $\gamma(T)$ is the relaxation parameter. The plasma model is obtained from Eq. (6) by putting the relaxation parameter equal to zero,

$$\varepsilon_{l,p}^{(0)} = 1 + \frac{\omega_p^2}{\xi_l^2}.$$
(7)

As mentioned in Sec. I, the Drude model (6) takes into account the relaxation properties of conduction electrons. In classical electromagnetic fields it is applicable at low frequencies. The plasma model (7) disregards the relaxation properties of conduction electrons. In classical fields it is applicable in the region of infrared optics. Both quantities (6) and (7) can be continued to the plane of complex frequencies as the analytic functions satisfying all the demands required from the dielectric permittivity [43]. Specifically, they satisfy the Kramers-Kronig relations between their real and imaginary parts formulated for the functions having the first- and secondorder poles at zero frequency, respectively [60].

We begin from calculation of the zero-frequency contribution to Eq. (1) in the case of the Drude model,

$$\mathcal{F}_{D}^{(l=0)}(a,T) = \mathcal{F}_{D,\,\text{TM}}^{(l=0)}(a,T) + \mathcal{F}_{D,\,\text{TE}}^{(l=0)}(a,T).$$
(8)

Using Eq. (6), we obtain from Eq. (3) that $k_0^{(n)}(k_{\perp}) = k_{\perp}$ and Eq. (2) results in

$$r_{\rm TM}^{(0,\pm1)}(0.k_{\perp}) = -1, \qquad r_{\rm TE}^{(0,\pm1)}(0.k_{\perp}) = 0.$$
 (9)

Then, using Eqs. (1) and (8), we obtain

$$\mathcal{F}_{D,\,\mathrm{TM}}^{(l=0)}(a,T) = \frac{k_B T}{4\pi} \int_0^\infty k_\perp dk_\perp \ln(1 - e^{-2ak_\perp})$$
$$= -\frac{k_B T}{16\pi a^2} \zeta(3), \quad \mathcal{F}_{D,\,\mathrm{TE}}^{(l=0)}(a,T) = 0, \quad (10)$$

where $\zeta(z)$ is the Riemann zeta function. This result does not depend on the type of dielectric materials of the plates on both sides of the metallic film and metal used. Note that the same result (the so-called classical limit) is obtained for the wellstudied configuration of two metallic semispaces separated by a dielectric film [3]. As shown below, however, in the present case of metallic film the classical limit is achieved at much shorter separations than for two metallic semispaces.

Now we consider the case of plasma model (7). Here, like for the Drude model, $k_0^{(\pm 1)}(k_{\perp}) = k_{\perp}$ but

$$k_0^{(0)}(k_\perp) = \sqrt{k_\perp^2 + \frac{\omega_p^2}{c^2}}.$$
 (11)

As a result,

$$r_{\rm TM}^{(0,\pm1)}(0.k_{\perp}) = -1, \quad r_{\rm TE}^{(0,\pm1)}(0.k_{\perp}) = \frac{\sqrt{k_{\perp}^2 + \frac{\omega_p^2}{c^2} - k_{\perp}}}{\sqrt{k_{\perp}^2 + \frac{\omega_p^2}{c^2} + k_{\perp}}},$$
(12)

and for the TM contribution to the Casimir free energy defined like in Eq. (8) one obtains

$$\mathcal{F}_{p,\,\mathrm{TM}}^{(l=0)}(a,T) = \frac{k_B T}{4\pi} \int_0^\infty k_\perp dk_\perp \ln\left(1 - e^{-2a\sqrt{k_\perp^2 + \frac{\omega_p^2}{c^2}}}\right)$$
$$= -\frac{k_B T}{4\pi} \sum_{n=1}^\infty \frac{1}{n} \int_0^\infty k_\perp dk_\perp e^{-2an\sqrt{k_\perp^2 + \frac{\omega_p^2}{c^2}}}.$$
 (13)

Calculating the integral in Eq. (13), we finally have

$$\mathcal{F}_{p,\,\mathrm{TM}}^{(l=0)}(a,T) = -\frac{k_B T}{16\pi a^2} \sum_{n=1}^{\infty} \frac{1}{n^3} \left(1 + \frac{2an\omega_p}{c} \right) e^{-2an\omega_p/c}$$
$$= -\frac{k_B T}{16\pi a^2} [\tilde{\omega}_p \operatorname{Li}_2(e^{-\tilde{\omega}_p}) + \operatorname{Li}_3(e^{-\tilde{\omega}_p})], \quad (14)$$

where $\text{Li}_n(z)$ is the polylogarithm function and $\tilde{\omega}_p = 2a\omega_p/c$. As is seen in Eq. (14), in our configuration the TM contribution to $\mathcal{F}_p^{(l=0)}$ is not similar to Eq. (10) and decreases exponentially with increasing film thickness. The physical meaning of this dependence is explained below.

The TE contribution to the zero-frequency term in the case of the plasma model is a more complicated quantity. To calculate it, we use Eqs. (1), (11), and (12) and introduce the new dimensionless variable $u = 2ak_{\perp}$ with a result,

$$\mathcal{F}_{p,\,\mathrm{TE}}^{(l=0)}(a,T) = \frac{k_B T}{16\pi a^2} \int_0^\infty u du \ln\left[1 - r_{\mathrm{TE}}^2(0,u)e^{-\sqrt{u^2 + \hat{\omega}_p^2}}\right],\tag{15}$$

where

$$r_{\rm TE}(0,u) \equiv r_{\rm TE}^{(0,\pm1)}(0,u) = \frac{\sqrt{u^2 + \tilde{\omega}_p^2 - u}}{\sqrt{u^2 + \tilde{\omega}_p^2 + u}}.$$
 (16)

Now we notice that $1/\tilde{\omega}_p = c/(2a\omega_p) = \delta/(2a)$. Here, $\delta = c/\omega_p = \lambda_p/(2\pi)$, where λ_p is the plasma wavelength, has the meaning of the effective penetration depth of the electromagnetic oscillations into a metal. For Au, for instance, $\omega_p = 9 \text{ eV}$ [61] and $\delta \approx 22 \text{ nm}$. Thus, at $a \ge 110 \text{ nm}$ the quantity $1/\tilde{\omega}_p$ can be considered as a small parameter. Expanding the pre-exponent in Eq. (15) in powers of this parameter, one obtains

$$r_{\rm TE}^2(0,u) = 1 - \frac{4u}{\tilde{\omega_p}} + \frac{8u^2}{\tilde{\omega_p}^2}.$$
 (17)

Taking into account that for the same film thickness $\exp(-\sqrt{u^2 + \tilde{\omega}_p^2})$ is an even much smaller parameter, one can expand the logarithm in Eq. (15) and find using Eq. (17),

$$\ln\left[1 - r_{\rm TE}^{2}(0,u)e^{-\sqrt{u^{2} + \tilde{\omega}_{p}^{2}}}\right] = -\left(1 - \frac{4u}{\tilde{\omega}_{p}} + \frac{8u^{2}}{\tilde{\omega}_{p}^{2}}\right)e^{-\sqrt{u^{2} + \tilde{\omega}_{p}^{2}}}.$$
 (18)

Substituting Eq. (18) in Eq. (15) and performing all integrations with respect to u, we have

$$\mathcal{F}_{p,\,\mathrm{TE}}^{(l=0)}(a,T) = -\frac{k_B T}{16\pi a^2} \bigg[\tilde{\omega}_p \, e^{-\tilde{\omega}_p} - 4\tilde{\omega}_p \, K_2(\tilde{\omega}_p) \\ + \bigg(17 - \frac{48}{\tilde{\omega}_p} + \frac{48}{\tilde{\omega}_p^2} \bigg) e^{-\tilde{\omega}_p} \bigg], \tag{19}$$

where $K_n(z)$ is the Bessel function of the imaginary argument. Using the asymptotic expression for this function at large argument and preserving only the main term in Eq. (19), we obtain

$$\mathcal{F}_{p,\,\mathrm{TE}}^{(l=0)}(a,T) = -\frac{k_B T}{16\pi a^2} \tilde{\omega}_p \left(1 - \sqrt{\frac{8\pi}{\tilde{\omega}_p}} + \frac{17}{\tilde{\omega}_p}\right) e^{-\tilde{\omega}_p}.$$
 (20)

Note that the first term on the right-hand side of this equation is equal to the main term of the quantity $\mathcal{F}_{p,\text{TM}}^{(l=0)}$ defined in Eq. (14). The entire quantity $\mathcal{F}_{p,\text{TE}}^{(l=0)}$ decreases exponentially with increasing film thickness, as does the quantity $\mathcal{F}_{p,\text{TM}}^{(l=0)}$. Notice also that a similar expression for the configuration of two metallic plates separated by a dielectric layer contains the perturbation expansion in powers of $1/\tilde{\omega}_p$, whereas in Eq. (20) the expansion parameter is $1/\sqrt{\tilde{\omega}_p}$. By summing the main contributions in Eqs. (14) and (20), we find the main term in the Casimir free energy $\mathcal{F}_p^{(l=0)}$ calculated using the plasma model,

$$\mathcal{F}_p^{(l=0)}(a,T) = -\frac{k_B T}{8\pi a^2} \tilde{\omega}_p e^{-\tilde{\omega}_p}.$$
(21)

We are coming now to the contribution of Matsubara terms with $l \ge 1$ to the Casimir free energy. It turns out that their role is radically different when the metallic film is described either by the Drude or by the plasma model. We start from the case of the Drude model (6). In this case simple estimations show (see the Appendix) that for film thicknesses exceeding 110 nm the contribution of all Matsubara terms with $l \ge 1$ is negligibly small, as compared to the zero-frequency term (10). Thus, for our configuration of a metallic film sandwiched between two dielectric plates the classical limit is reached for surprisingly thin films if a metal is characterized by the Drude model (recall that for two metallic plates separated by a dielectric layer the classical limit starts at separations exceeding about $6 \mu m$). This fact does not depend on a material of the dielectric plates.

When the metallic film is described by the plasma model (7), numerical computations show that the contribution of all Matsubara terms with nonzero frequency to the Casimir free energy does not become smaller than the classical term (21) up to very large film thicknesses. Thus, for an Au film of more than 1- μ m thickness in vacuum at room temperature (T = 300 K)

the main term in the contribution of all Matsubara frequencies with $l \ge 1$ is given by (see the Appendix)

$$\mathcal{F}_{p}^{(l\geq 1)}(a,T) = -\frac{k_{B}T}{4\pi a^{2}} \tilde{\omega}_{p} e^{-\tilde{\omega}_{p}} \sum_{l=1}^{\infty} e^{-\zeta_{l}^{2}/(2\tilde{\omega}_{p})}.$$
 (22)

From Eqs. (21) and (22) one finds that for film thicknesses of 6, 30, and 50 μ m the ratio $\mathcal{F}_p^{(l\geq 1)}/\mathcal{F}_p^{(l=0)}$ is equal to 4.95, 1.66, and 1.06, respectively. Only for a film thickness $a = 100 \,\mu$ m this ratio becomes less than unity (it is equal to 0.46). But even in this case the classical limit is not yet achieved. Note also that at 100 μ m the exponential factor exp $(-\tilde{\omega}_p)$ is equal to 2.5 × 10⁻³⁵⁶⁶, i.e., the problem has no physical meaning.

It is important to underline that the main contribution to the Casimir free energy is of quantum origin because the power of the exponent in Eq. (22) depends on the Planck constant,

$$\frac{\zeta_l^2}{2\tilde{\omega}_p} = \frac{a(2\pi k_B T l)^2}{c\omega_p \hbar^2}.$$
(23)

Thus, in the configuration of a metallic film sandwiched between two dielectric plates the Casimir free energy has no classical limit if the metal of a film is described by the plasma model. Such a radical difference with the case of the Drude metallic film, where the classical limit is reached, but for surprisingly small film thicknesses, deserves a discussion.

To address this point, we consider the behavior of the Casimir free energy in the limiting case $\omega_p \rightarrow \infty$. In this limit the metal of a film is usually supposed to turn into an ideal metal characterized by the infinitely large magnitude of dielectric permittivity at all frequencies. At the surface of an ideal metal the tangential component of electric field, as well as the normal component of magnetic induction, must vanish. This reflects the fact that electromagnetic oscillations cannot penetrate in the interior of an ideal metal film and, thus, the Casimir free energy of such a film must be equal to zero.

It is interesting to verify whether the above results, obtained using the Drude and the plasma models, satisfy this physical requirement. In the case of the plasma model from Eqs. (21) and (22) we immediately arrive at

$$\lim_{\omega_p \to \infty} \mathcal{F}_p(a, T) = 0.$$
 (24)

Thus, if real metal is described by the plasma model, the Casimir free energy caused by quantum fluctuations of the electromagnetic field, vanishes when the metal becomes an ideal one, as it should be.

Another situation holds for the Drude model. In this case from Eqs. (10) and (A8) we find that

$$\lim_{\omega_p \to \infty} \mathcal{F}_D(a, T) = -\frac{k_B T}{16\pi a^2} \zeta(3), \tag{25}$$

i.e., the ideal metal film is characterized by a nonzero Casimir free energy contrary to physical intuition.

In the next sections the above results are supported by numerical computations performed for real metal films both in vacuum and situated between two dielectric plates made of some specific dielectric material. It should be pointed out that similar results also hold for the configuration of a metallic film deposited on a dielectric substrate.

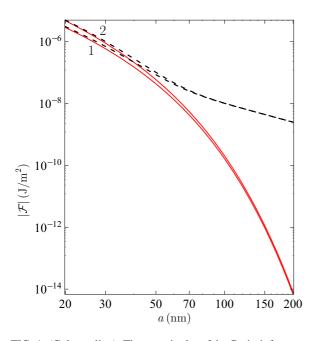


FIG. 1. (Color online) The magnitudes of the Casimir free energy per unit area at T = 300 K computed using the Drude model (dashed lines) and the plasma model (solid lines) approaches are plotted in the double logarithmic scale versus the film thickness for an Au film sandwiched between two sapphire plates (the pair of lines 1) and for an Au film in vacuum (the pair of lines 2).

III. COMPUTATIONS OF THE CASIMIR FREE ENERGY OF GOLD FILMS

Here, we compute the Casimir free energy of an Au film. The dielectric permittivity of Au $\varepsilon_l^{(0)}$ at the imaginary Matsubara frequencies is obtained from the tabulated optical data for the complex index of refraction [61] extrapolated to zero frequency using either the Drude or the plasma model (see Refs. [1,3] for details). The film is either in vacuum or sandwiched between two thick sapphire plates (thicker than about 2- μ m plate can be already considered as a semispace with respect to the Casimir effect [3]). For the dielectric permittivity of sapphire at the imaginary Matsubara frequencies there is a rather precise analytic expression [62],

$$\varepsilon_l^{(\pm 1)} = 1 + \frac{C_{\rm IR} \,\omega_{\rm IR}^2}{\omega_{\rm IR}^2 + \xi_l^2} + \frac{C_{\rm UV} \,\omega_{\rm UV}^2}{\omega_{\rm UV}^2 + \xi_l^2},\tag{26}$$

where $C_{\rm UV} = 2.072$, $C_{\rm IR} = 7.03$, $\omega_{\rm UV} = 2.0 \times 10^{16}$ rad/s, and $\omega_{\rm IR} = 1.0 \times 10^{14}$ rad/s. All computations have been performed using the Lifshitz formula (1) written in terms of dimensionless variables u and ζ_l [see Eq. (A1)].

In Fig. 1 we plot the magnitudes of the Casimir free energy per unit area at T = 300 K computed using the Drude (the dashed lines) and the plasma (the solid lines) model approaches as the functions of film thickness in the configurations of an Au film sandwiched between two sapphire plates (the pair of solid and dashed lines numbered 1) and for an Au film in vacuum (the pair of lines numbered 2). The computational results are presented in the double logarithmic scale.

As is seen in Fig. 1, in each configuration the theoretical predictions of the plasma and Drude model approaches

are almost coinciding for the smallest film thickness. With increasing thickness of an Au film the predictions of both approaches differ considerably. Thus, for the configuration of a sandwiched film of thicknesses 50, 100, and 200 nm the magnitudes of the free energies predicted by the Drude model approach are larger than those predicted by the plasma model approach by the factors of 1.97, 61.9, and 3.6×10^5 , respectively. In doing so, the values of the Casimir free energy for the films of 50- and 100-nm thickness calculated according to the plasma model approach are equal to -42.95 and -0.1633 pJ/m², respectively.

For Au films of 50-, 100-, and 200-nm thickness in vacuum the predictions of the Drude model approach are larger than for the plasma one by the factors of 1.72, 50.45, and 3.17×10^5 , respectively. In this case the respective values of the Casimir free energy for the films of 50- and 100-nm thickness computed using the plasma model approach are -58.60 and -0.2012 pJ/m^2 .

It is interesting that the predictions of the Drude model approach for the Casimir free energy in the two configurations under consideration (the sandwiched Au film and the Au film in vacuum) are almost coinciding for film thicknesses $a \ge 100$ nm (they are equal up to 0.4% at 100 nm and have at least four significant figures common at $a \ge 180$ nm). If, however, the plasma model approach is used, the magnitudes of the Casimir free energy predicted for the Au films of thicknesses 100 and 200 nm in vacuum are larger than those for a sandwiched film by the factors of 1.23 and 1.15, respectively. This means that when the plasma model approach is used in computations, the difference in theoretical predictions for different configurations is preserved for much larger film thicknesses than for the Drude model approach. This is explained by the fact that for metallic films described by the Drude model the classical limit is already achieved for the film thickness of about 110 nm (see Sec. II).

Now we consider the smaller film thicknesses, where the Casimir free energy does not depend on whether the plasma or the Drude model approach is used in computations, and investigate the role of relativistic effects. In the nonrelativistic limit $r_{TE}^{(0,\pm 1)} = 0$ and in terms of the dimensionless variables one obtains

$$\mathcal{F}_{D(p)}(a,T) = \frac{k_B T}{8\pi a^2} \sum_{l=0}^{\infty} \int_0^\infty u \, du \\ \times \ln\left[1 - r_{\text{TM}}^{(0,+1)}(i\zeta_l) r_{\text{TM}}^{(0,-1)}(i\zeta_l) e^{-u}\right], \quad (27)$$

where

$$r_{\rm TM}^{(0,\pm1)}(i\zeta_l) = \frac{\varepsilon_l^{(\pm1)} - \varepsilon_l^{(0)}}{\varepsilon_l^{(\pm1)} + \varepsilon_l^{(0)}}.$$
 (28)

Note that the same computational results for small film thicknesses are obtained if we change the discrete Matsubara frequencies ζ_l in Eqs. (27) and (28) with the continuous variable and make a replacement,

$$k_B T \sum_{l=0}^{\infty} {}' \to \frac{\hbar c}{4\pi a} \int_0^\infty d\zeta.$$
 (29)

As a result, the quantity (27) does not depend on T and gives the Casimir energy per unit area.

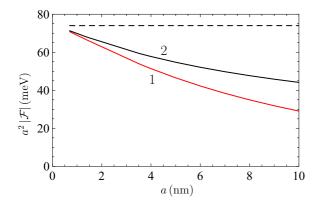


FIG. 2. (Color online) The magnitudes of the Casimir free energy per unit area at T = 300 K are plotted for an Au film in vacuum versus the film thickness (line 1) and for two Au plates separated with a vacuum gap versus the gap width (line 2). The common nonrelativistic results for the Casimir energy per unit area in these configurations are shown by the dashed line.

In Fig. 2 we present the common computational results, obtained using the Drude or the plasma model approach for the magnitude of the nonrelativistic Casimir energy (27) of an Au film in vacuum, multiplied by the separation squared, as a function of *a* (the dashed line). As is seen from Eqs. (27) and (28), in the case $\varepsilon_l^{(+1)} = \varepsilon_l^{(-1)}$ the free energy \mathcal{F} is unchanged if one replaces $\varepsilon_l^{(+1)}$ with $\varepsilon_l^{(0)}$ and vice versa. This means that in the nonrelativistic limit the dashed line in Fig. 2 also presents the Casimir energy in the configuration of two Au plates separated with a vacuum gap.

For comparison purposes, the solid lines 1 and 2 in Fig. 2 show the fully relativistic computational results for the magnitudes of the Casimir free energy per unit area multiplied by a^2 in the configurations of an Au film in vacuum and of two Au plates separated with a vacuum gap, respectively. As is seen in Fig. 2, even for the smallest film thickness a = 1 nm there is a detectable difference (of approximately 3 meV) between the nonrelativistic and relativistic computational results. This difference increases with increasing film thickness. For example, for a film of 10-nm thickness the relativistic result for an Au film in vacuum (the line 1) differs from the nonrelativistic one by 45 meV. The relativistic (the line 2) and the nonrelativistic (the dashed line) results in the configuration of two Au plates separated with a vacuum gap of 10-nm width differ by 30 meV. Thus, from Fig. 2 it is seen that the relativistic effects play an important role even for the thinnest Au films.

From this figure it is also seen that in the relativistic case the magnitudes of the free energy of two Au plates separated with a vacuum gap (the line 2) are somewhat larger than for an Au film in vacuum (the line 1). The difference between them increases with increasing width of the gap (film thickness) and achieves 15 meV for a = 10 nm.

For the configuration of an Au film sandwiched between two sapphire plates the computational results for the Casimir free energy and energy are similar to those shown in Fig. 2.

Now we consider the dependence of the Casimir free energy of a metallic film of the fixed thickness on the temperature. When the plasma model approach is used in computations, the temperature dependence may arise only through the



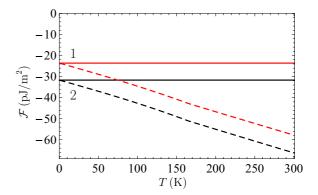


FIG. 3. (Color online) The Casimir free energy per unit area for the film thickness a = 55 nm computed using the Drude model (dashed lines) and the plasma model (solid lines) approaches are plotted versus temperature for an Au film sandwiched between two sapphire plates (the pair of lines 1) and for an Au film in vacuum (the pair of lines 2).

summation over the Matsubara frequencies and the factor k_BT in Eq. (1). For the Drude model approach there is also an additional temperature dependence through the relaxation parameter in Eq. (6). Thus, to find the free energy at different temperatures, one should use this dependence in computations.

As was mentioned above, for Au at T = 300 K the relaxation parameter $\gamma(T) = 0.035$ eV. Within the temperature interval from room temperature down to $T_D/4$, where T_D is the Debye temperature, the linear dependence $\gamma(T) \sim T$ is preserved (note that for Au $T_D = 165$ K [63]). In the interval from $T_D/4$ down to the temperature of helium liquefaction $\gamma(T) \sim T^5$ according to the Bloch-Grüneisen law [64], and at liquid helium temperatures $\gamma(T) \sim T^2$ holds [63].

The computations of the Casimir free energy as a function of temperature are performed for the film thickness a =55 nm, where the predictions of the plasma and Drude model approaches differ, at room temperature, by roughly a factor of two. The same equations as above have been used, but the temperature dependence of the relaxation parameter was taken into account. The computational results are shown in Fig. 3. The pairs of lines numbered 1 and 2 are obtained for a Au film sandwiched between two sapphire plates and for an Au film in vacuum, respectively. For both configurations the solid lines are computed using the plasma model approach and the dashed lines by the Drude model approach.

As is seen in Fig. 3, the magnitudes of the Casimir free energy of an Au film in vacuum are larger than for a sandwiched film. This is in agreement with Fig. 1. It is seen also that in the temperature interval from 0 to 300 K the Casimir free energy computed using the plasma model approach does not depend on temperature for both configurations under consideration. In fact for all reasonable film thicknesses, when the Casimir free energy is not too small, the computational results using the plasma model approach do not depend on the temperature. The dashed lines in Fig. 3 demonstrate the strong linear dependence of the Casimir free energy on temperature when the Drude model approach is used in computations. This dependence is caused by the contribution of the zero-temperature term (10) to the Casimir free energy

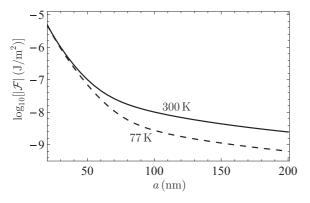


FIG. 4. The magnitudes of the Casimir free energy per unit area at T = 300 K (the solid line) and T = 77 K (the dashed lines) computed using the Drude model approach for an Au film in vacuum are plotted versus the film thickness.

and by the fact that the contribution of all Matsubara terms with $l \ge 1$ is rather small even for rather thin metallic films.

To illustrate the role of temperature in the Drude model approach, in Fig. 4 we plot the magnitudes of the Casimir free energy versus film thickness computed at T = 300 K (the solid line) and at T = 77 K (the dashed line). In agreement with Fig. 3, at larger temperature the magnitude of the Casimir free energy is larger for each fixed film thickness. However, for thin films (a < 30 nm) the effect of temperature is negligibly small. For films of thicknesses equal to 50, 100, and 200 nm the ratio of the Casimir free energy at T = 300 K to that at T = 77 K is equal to 1.4, 3.7, and 3.9, respectively. This demonstrates that the thermal effect predicted by the Drude model approach contributes a lot even for not too thick metallic films (note that for a = 200 nm the ratio of free energies indicated above is equal to the ratio of temperatures $300/77 \approx 3.9$).

IV. CASIMIR PRESSURE FOR METALLIC FILMS

The Casimir pressure is obtained from the Casimir free energy per unit area by the negative differentiation with respect to the film thickness,

$$P(a,T) = -\frac{\partial \mathcal{F}(a,T)}{\partial a},$$
(30)

where $\mathcal{F}(a,T)$ is given by Eq. (1). Using the dimensionless variables, one obtains

$$P_{D(p)}(a,T) = -\frac{k_B T}{8\pi a^3} \sum_{l=0}^{\infty} \int_0^\infty \sqrt{u^2 + \varepsilon_{l,D(p)}^{(0)} \zeta_l^2} u \, du$$

$$\times \left\{ \left[\frac{e^{\sqrt{u^2 + \varepsilon_{l,D(p)}^{(0)} \zeta_l^2}}}{r_{\text{TM}}^{(0,+1)}(i\zeta_l,u) r_{\text{TM}}^{(0,-1)}(i\zeta_l,u)} - 1 \right]^{-1} + \left[\frac{e^{\sqrt{u^2 + \varepsilon_{l,D(p)}^{(0)} \zeta_l^2}}}{r_{\text{TE}}^{(0,+1)}(i\zeta_l,u) r_{\text{TE}}^{(0,-1)}(i\zeta_l,u)} - 1 \right]^{-1} \right\}.$$
(31)

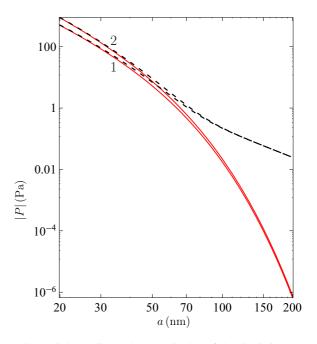


FIG. 5. (Color online) The magnitudes of the Casimir pressure at T = 300 K computed using the Drude model (dashed lines) and the plasma model (solid lines) approaches are plotted in the double logarithmic scale versus the film thickness for an Au film sandwiched between two sapphire plates (the pair of lines 1) and for an Au film in vacuum (the pair of lines 2).

Similar to the case of the free energy, for the Drude model approach the zero-frequency term in the Casimir pressure (31) becomes dominant for film thicknesses exceeding 110 nm. Under this condition the Casimir pressure in both configurations of a metallic film sandwiched between two dielectric plates or for a metallic film in vacuum is given by

$$P_D(a,T) \approx P_{D,\text{TM}}^{(l=0)}(a,T) = -\frac{k_B T}{8\pi a^3} \zeta(3).$$
 (32)

For the plasma model approach under the condition $\tilde{\omega}_p \gg 1$ the contribution of the zero-frequency term to the Casimir pressure is given by

$$P_p^{(l=0)}(a,T) = -\frac{k_B T}{8\pi a^3} \tilde{\omega}_p^2 e^{-\tilde{\omega}_p}.$$
(33)

In this case, however, the contribution of nonzero Matsubara terms is not small, as compared to the quantity (33), for all physically reasonable film thicknesses. Thus, if the plasma model approach is used in computations, the classical limit for the Casimir pressure is not reached. In the limiting case $\omega_p \rightarrow \infty$ the Casimir pressure calculated using the plasma model approach vanishes. As to the Drude model approach, the Casimir pressure for a metallic film goes to the classical limit (32) for any film thickness, i.e., is nonzero when $\omega_p \rightarrow \infty$. This is in contradiction to the fact that electromagnetic oscillations cannot penetrate into an ideal metal.

Now we present the results of numerical computations of the Casimir pressure for Au films. The magnitudes of the Casimir pressure at T = 300 K computed using Eq. (31) in the framework of the Drude model (the dashed lines) and the plasma model (the solid lines) approaches as the functions of film thickness are shown in Fig. 5 for an Au film between

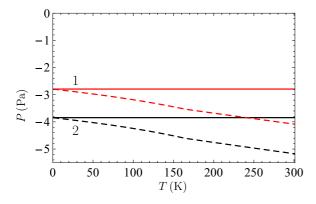


FIG. 6. (Color online) The Casimir pressure for the film thickness a = 55 nm computed using the Drude model (dashed lines) and the plasma model (solid lines) approaches are plotted versus temperature for an Au film sandwiched between two sapphire plates (the pair of lines 1) and for an Au film in vacuum (the pair of lines 2).

two sapphire plates (the pair of lines 1) and for an Au film in vacuum (the pair of lines 2). Similar to the free energy, for small film thicknesses below 30 nm the plasma and Drude model approaches lead to almost coinciding results in both configurations. However, for the configuration of an Au film between sapphire plates for film thicknesses of 50, 100, and 200 nm the magnitudes of the Casimir pressure calculated using the Drude model approach are larger than those calculated by the plasma model approach by the factors of 1.33, 12.7, and 3.73×10^4 , respectively. The values of the Casimir pressure for the films of 50- and 100-nm thickness, calculated by the plasma model approach, are equal to 5.21 and 0.0172 Pa, respectively.

According to Fig. 5, the Casimir pressures for Au films of 50-, 100-, and 200-nm thickness in vacuum calculated using the Drude model approach are larger than those calculated by the plasma model one by the factors of 1.24, 10.4, and 3.22×10^4 , respectively. For Au films of 50- and 100-nm thickness the respective values of the Casimir pressure calculated in the framework of the plasma model approach are equal to 7.318 and 0.0245 Pa.

Similar to the Casimir free energy, the values of the Casimir pressure predicted by the Drude model approach for $a \ge 100$ nm do not depend on the configuration (either a sandwiched Au film or an Au film in vacuum). For the plasma model approach, however, some differences in the values of the Casimir pressure in different configurations are preserved up to much larger film thicknesses (see Fig. 5). In the same way as for the Casimir free energy, the relativistic effects contribute considerably to the Casimir pressure even for Au films of smallest thicknesses.

We are coming now to computation of the Casimir pressure at different temperatures. This is done using Eq. (31) and taking into account the dependence of the relaxation parameter on T(see Sec. III). The computational results for a = 55 nm are shown in Fig. 6, where the Casimir pressures for an Au film between two sapphire plates and for an Au film in vacuum are shown versus temperature by the pairs of lines 1 and 2, respectively (the solid lines are computed using the plasma model approach and the dashed lines by the Drude model approach). From Fig. 6 it is seen that in the temperature region from 0 to 300 K the Casimir pressures computed using the plasma model approach do not depend on T. This is qualitatively the same as it holds for the Casimir free energy (see Fig. 3) and is explained by the same reasons. The linear dependence of the Casimir pressure computed using the Drude model approach on T is caused by the dominant contribution of the zero-frequency term (33). Similar to the Casimir free energy, at each fixed temperature the magnitudes of the Casimir pressure for an Au film in vacuum are somewhat larger than for an Au film sandwiched between two sapphire plates.

V. CONCLUSIONS AND DISCUSSION

In the foregoing, we have investigated the Casimir effect for metallic films between dielectric plates and found that it possesses unusual properties which have not been discussed in the previous literature. The most striking feature of this configuration is that the theoretical predictions of the Lifshitz theory using the Drude and the plasma model approaches differ significantly even for very thin films of a few tens nanometer thickness. This is different from previous understanding for the case of two plates separated with a vacuum gap or a dielectric layer, where a difference by a factor of two between these approaches appeared only at large separations above $6 \,\mu m$. It is important that in our case the relatively large difference between the predictions of the two approaches is obtained not for the force differences [54–56] (the latter requires difference force measurements for the experimental test of the predicted effects), but for the separate values of the free energy and pressure, as this holds at large separation distances.

Another interesting feature is the conceptual difference between the predictions of the Drude and plasma model approaches for metallic films. For the previously considered configurations at large separations (high temperatures) the classical limits were achieved in the framework of both theoretical approaches, but the values of the Casimir free energy and pressure differed by a factor of two. We have shown that for metallic films the classical limit is achieved for thin films of about 100-nm thickness and only if the Drude model approach is used. If the metallic film is described by the plasma model approach, the classical limit is not achieved for any reasonable film thickness and the Casimir effect has an entirely quantum character. In this case the Casimir free energy and pressure are decreasing exponentially to zero with increasing film thickness and differences with theoretical predictions of the Drude model approach quickly reach several orders of magnitude.

The described difference between the theoretical predictions of both approaches thus has the far-reaching consequences. According to our results, the Casimir free energy of a metallic film described by the Drude model approach goes to a nonzero classical value when the plasma frequency goes to infinity. This is contrary to physical intuition which suggests that electromagnetic fluctuations cannot penetrate into an ideal metal film, and, thus, its Casimir free energy should be equal to zero. It should be emphasized, that the Casimir free energy of a metallic film calculated using the plasma model approach vanishes when the plasma frequency goes to infinity in accordance with physical intuition.

This raises the question as to why the Drude model which has been successfully tested in thousands of experiments and in infinitely many technological applications fails to describe the experimental data of the most precise experiments on measuring the Casimir force, leads to violation of the Nernst heat theorem in the Lifshitz theory of dispersion forces and to counterintuitive results in the limiting case of ideal metal. Taking into account that the Drude model is valid for classical electromagnetic fields, one can guess that the reason is fundamentally related to the quantum nature of electromagnetic fluctuations giving rise to dispersion forces (we stress, that even in the classical limit, which holds in the configuration of two plates separated with a gap, there are quantum corrections to the classical values of the Casimir free energy and pressure depending on the Planck constant). If this is the case, the apparent contradiction of the Bohr-van Leeuwen theorem with the plasma model approach [44] (see Sec. I) would simply mean that the electromagnetic fluctuations responsible for dispersion forces cannot be considered as classical. Then, the Bohr-van Leeuwen theorem will play the same role, as it had originally played in the beginning of the last century by stating that the ferromagnetic properties of metals cannot be explained in the framework of classical physics.

Finally, it is pertinent to note that the effects described above can be observed not only in the plane parallel configurations (for solid films it is not difficult to achieve parallelity), but in the more popular sphere-plate geometry as well. For this purpose, the solid Au film should be replaced with a liquid metal like mercury or, more conveniently, with an alloy of gallium and indium which is liquid at room temperature. Then, in accordance with the proximity force approximation, the Casimir force is proportional to the Casimir free energy calculated in Secs. II and III. This opens opportunities for further experimental tests of the Lifshitz theory of dispersion forces in novel configurations and for the resolution of existing problems.

APPENDIX

In this Appendix we determine the contribution of the Matsubara terms with $l \ge 1$ to the Casimir free energy (1) when the film material is described either by the Drude or by the plasma model.

We begin with the Drude model (6). It is convenient to use the dimensionless variable $u = 2ak_{\perp}$, introduced in Sec. II, and the dimensionless Matsubara frequencies $\zeta_l = 2a\xi_l/c$. Then the contribution of all Matsubara terms with $l \ge 1$ to Eq. (1) for any dielectric function can be written in the form,

$$\begin{aligned} \mathcal{F}_{D(p)}^{(l \ge 1)}(a,T) \\ &\equiv \frac{k_B T}{8\pi a^2} \, S_{D(p)}(a,T) = \frac{k_B T}{8\pi a^2} \, \sum_{l=1}^{\infty} \int_0^\infty u \, du \\ &\times \big\{ \ln \big[1 - r_{\text{TM}}^{(0,+1)}(i\zeta_l,u) r_{\text{TM}}^{(0,-1)}(i\zeta_l,u) e^{-\sqrt{u^2 + \varepsilon_{l,D(p)}^{(0)} \xi_l^2}} \big] \\ &+ \ln \big[1 - r_{\text{TE}}^{(0,+1)}(i\zeta_l,u) r_{\text{TE}}^{(0,-1)}(i\zeta_l,u) e^{-\sqrt{u^2 + \varepsilon_{l,D(p)}^{(0)} \xi_l^2}} \big] \big\}, \end{aligned}$$
(A1)

where the reflection coefficients are given by Eq. (2), but $k_l^{(n)}(k_{\perp})$ are replaced with $k_l^{(n)}(u) = \sqrt{u^2 + \varepsilon_l^{(n)} \zeta_l^2}$.

Now we consider the quantity $\tilde{S}_D(a,T)$, which is defined in the same way as $S_D(a,T)$ in Eq. (A1), but with the product of the reflection coefficients replaced with unity. It is evident that

$$|S_D(a,T)| < |\tilde{S}_D(a,T)|$$

= $-2\sum_{l=1}^{\infty} \int_0^{\infty} u \, du \ln\left(1 - e^{-\sqrt{u^2 + \varepsilon_{l,D}^{(0)} \zeta_l^2}}\right).$ (A2)

Using Eq. (6) rewritten in terms of dimensionless variables,

$$\varepsilon_{l,D}^{(0)} = 1 + \frac{\tilde{\omega}_p^2}{\zeta_l(\zeta_l + \tilde{\gamma})},\tag{A3}$$

where $\tilde{\gamma} = 2a\gamma/c$ is the dimensionless relaxation parameter, it is easily seen that for film thicknesses a > 110 nm the quantity $\varepsilon_{l,D}^{(0)}\zeta_l^2$ remains large for all $l \ge 1$. Expanding the right-hand side of Eq. (A2) in powers of a small exponent and integrating with respect to u, one arrives at

$$|S_D(a,T)| < 2\sum_{l=1}^{\infty} \sum_{n=1}^{\infty} \frac{1}{n^3} \left(1 + n\sqrt{\varepsilon_{l,D}^{(0)}} \zeta_l \right) e^{-n\sqrt{\varepsilon_{l,D}^{(0)}} \zeta_l}.$$
 (A4)

Note that the account of the contribution of core electrons in the dielectric permittivity $\varepsilon_{l,D(p)}^{(0)}$ would only increase its value and, thus, decrease the upper bound of $|S_D|$ in Eq. (A4).

Using Eq. (A3) and an evident equality $\zeta_l = \zeta_1 l$, the quantity $\sqrt{\varepsilon_{l,D}^{(0)}} \zeta_l$ can be represented as

$$\sqrt{\varepsilon_{l,D}^{(0)}}\zeta_l = \sqrt{\zeta_l^2 + \tilde{\omega}_p^2 \frac{l}{l + \frac{\tilde{\gamma}}{\zeta_l}}}.$$
 (A5)

It is well known that at room temperature $\tilde{\gamma}/\zeta_1 = \gamma/\xi_1 < 1$. For instance, for Au we have $\gamma = 0.035$ eV and $\tilde{\gamma}/\zeta_1 = 0.21$. As a result, the minimum value of the ratio in Eq. (A5) is achieved at l = 1:

$$\min_{l} \frac{l}{l + \frac{\tilde{\gamma}}{l_{0}}} \approx \frac{1}{1 + 0.21} \approx 0.82.$$
 (A6)

On the other hand, the largest value of the same ratio, achieved at $l \rightarrow \infty$, is equal to unity. Now we reinforce the inequality (A4) by using Eq. (A6) in the power of the exponent, but substituting the largest value of the ratio in the pre-exponent:

$$|S_D(a,T)| < 2\sum_{l=1}^{\infty} \sum_{n=1}^{\infty} \left(\frac{1}{n^3} + \frac{1}{n^2}\sqrt{\zeta_l^2 + \tilde{\omega}_p^2}\right) e^{-n\sqrt{\zeta_l^2 + 0.82\tilde{\omega}_p^2}}.$$
(A7)

Calculating the sum with respect to *n*, we obtain

$$|S_{D}(a,T)| < 2 \sum_{l=1}^{\infty} \left[\text{Li}_{3} \left(e^{-\sqrt{\zeta_{l}^{2} + 0.82\tilde{\omega}_{p}^{2}}} \right) + \sqrt{\zeta_{l}^{2} + \tilde{\omega}_{p}^{2}} \text{Li}_{2} \left(e^{-\sqrt{\zeta_{l}^{2} + 0.82\tilde{\omega}_{p}^{2}}} \right) \right].$$
(A8)

We have computed the right-hand side of Eq. (A8) at T = 300 K. At a = 110 nm it is equal to 0.058 and quickly decreases with increase of separation. Thus, at a = 120 and 150 nm the right-hand side of Eq. (A8) is equal to 0.026 and 0.0024, respectively, and goes to zero at large separations. For

comparison purposes, the contribution of the zero-frequency term,

$$\frac{8\pi a^2}{k_B T} \left| \mathcal{F}_D^{(l=0)}(a,T) \right| = \frac{1}{2} \zeta(3) \approx 0.601, \tag{A9}$$

as it follows from Eqs. (8) and (10). Thus, for metallic films described by the Drude model, the classical limit holds for all film thicknesses exceeding 110 nm, as is stated in Sec. II.

Now we consider the contribution of all Matsubara terms with $l \ge 1$ to the Casimir free energy calculated using the plasma model. In analytic calculations we restrict ourselves by the case of an Au film in vacuum at T = 300 K. We assume that the film is sufficiently thick ($a \ge 1 \mu$ m). In this case $\tilde{\omega}_p \ge 91$. Taking into account that the Matsubara frequencies, giving the main contribution to the Casimir free energy, satisfy the condition $\xi_l \lesssim 10c/(2a)$, i.e., $\zeta_l \lesssim 10$, we arrive at the small parameter,

$$\frac{\zeta_l}{\sqrt{\zeta_l^2 + \tilde{\omega}_p^2}} \ll 1. \tag{A10}$$

In terms of dimensionless variables the plasma model is obtained from Eq. (A3) by putting $\tilde{\gamma} = 0$,

$$\varepsilon_{l,p}^{(0)} = 1 + \frac{\tilde{\omega}_p^2}{\zeta_l^2}.$$
(A11)

We substitute Eq. (A11) in Eq. (4), where k_{\perp} is replaced with u/(2a), and expanding in powers of the parameter (A10) find

$$r_{\rm TM}^{(0,\pm1)}(i\zeta_l,u) \approx -1 + \frac{2}{\sqrt{1 + \frac{u^2}{\zeta_l^2}}} \frac{\zeta_l}{\sqrt{\zeta_l^2 + \tilde{\omega}_p^2}},$$

$$r_{\rm TE}^{(0,\pm1)}(i\zeta_l,u) \approx 1 - 2\sqrt{1 + \frac{u^2}{\zeta_l^2}} \frac{\zeta_l}{\sqrt{\zeta_l^2 + \tilde{\omega}_p^2}}.$$
(A12)

Taking into account that under our conditions $\sqrt{1 + u^2/\zeta_l^2} \sim 1$, in the zeroth order of the small parameter

(A10) we can replace the TM and TE reflection coefficients with -1 and 1, respectively. As a result, the normalized contribution of all Matsubara terms with $l \ge 1$ in the Casimir free energy [see Eq. (A1)] is given by

$$S_p(a,T) = 2\sum_{l=1}^{\infty} \int_0^{\infty} u \, du \ln\left(1 - e^{-\sqrt{u^2 + \zeta_l^2 + \tilde{\omega}_p^2}}\right).$$
(A13)

After the expansion in powers of the small exponent and integrating with respect to u, we obtain

$$S_p(a,T) = -2\sum_{l=1}^{\infty}\sum_{n=1}^{\infty}\frac{1}{n^3} \left(1 + n\sqrt{\zeta_l^2 + \tilde{\omega}_p^2}\right) e^{-n\sqrt{\zeta_l^2 + \tilde{\omega}_p^2}}.$$
(A14)

The exponents in this equation decrease very fast due to the large values of $\tilde{\omega}_p > 91$. Because of this, we can omit all terms with $n \ge 2$ without loss of precision,

$$S_p(a,T) = -2\sum_{l=1}^{\infty} \left(1 + \sqrt{\zeta_l^2 + \tilde{\omega}_p^2}\right) e^{-\sqrt{\zeta_l^2 + \tilde{\omega}_p^2}}.$$
 (A15)

Expanding here in powers of the small parameter $\zeta_l/\tilde{\omega}_p$, we get

$$S_p(a,T) = -2\tilde{\omega}_p \sum_{l=1}^{\infty} \left(1 + \frac{1}{\tilde{\omega}_p} + \frac{\zeta_l^2}{2\tilde{\omega}_p^2} \right) e^{-\tilde{\omega}_p - \zeta_l^2/(2\tilde{\omega}_p)},$$
(A16)

and neglecting by $1/\tilde{\omega}_p$ and $\zeta_l^2/(2\tilde{\omega}_p^2)$ as compared with unity, finally arrive at

$$S_p(a,T) = -2\tilde{\omega}_p e^{-\tilde{\omega}_p} \sum_{l=1}^{\infty} e^{-\zeta_l^2/(2\tilde{\omega}_p)}.$$
 (A17)

After multiplication by the normalization factor $k_B T/(8\pi a^2)$, one obtains from Eq. (A17) the desired Eq. (22).

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